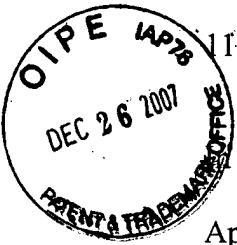


1FW 1722



1110/97962

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re U.S. Patent Application

Applicant(s): Masafumi Ura

Serial No.: 10/588,750

Filed: August 7, 2006

For: **Method for Manufacturing Single Crystal Semiconductor**

Examiner: Felisa Carla Hiteshew

) Art Unit: 1722

) Confirmation No.: 4524

) I hereby certify that this correspondence is
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) 
) Gerald T. Shekleton Reg. No. 27,466

AMENDMENT

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

The Office Action of September 21, 2007 has been carefully reviewed and the following amendments and remarks are made in response thereto: